

AP20 Rec'd PCT/PTO 30 JUN 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

## In Re PATENT APPLICATION Of:

Applicant : Mineo MIURA )

U.S. Appln. No. : To Be Assigned )

International Appln. No.: PCT/JP04/019662 )

International Filing Date: December 21, 2004 )

For : PRODUCTION METHOD FOR )  
SEMICONDUCTOR DEVICE )

Attorney Ref. : AI 418NP )

) INFORMATION  
) DISCLOSURE  
) STATEMENT

June 30, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

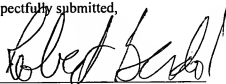
Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. § 1.97(b)(2).

Attached are copies of two Japanese patent publications, any relevance of which to the claimed invention can be gleaned from the attached English-language Abstracts, computer translations, the attached English-language international search report, and/or the discussion on page 3 of the specification. All of the publications are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§ 1.97 and 1.98 are deemed to be fully met as to all documents listed. Consideration of the listed documents is respectfully requested.

Respectfully submitted,



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June 30, 2006

Date

RHB:tl

**FEE ENCLOSED:\$**  
Please charge any further  
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.E./